



00862.022315

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2853

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
Mitsuru HIURA) : Examiner: A. Dudding
Application No.: 09/915,325) : Group Art Unit: 2853
Filed: July 27, 2001) : Confirmation No.: 5938
For: EXPOSURE APPARATUS AND DEVICE) :
MANUFACTURING METHOD USING THE :
SAME) January 21, 2004

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AFTER FINAL REJECTION

Sir:

In response to the Official Action dated November 4, 2003, please amend the above-identified application as follows: